

Refine Search

for 10/685,588

Search Results -

Terms	Documents
(ebr or (bevel adj edge)) same (cmp or polish\$4 or clean\$4 or remov\$3) same wafer	192

Database:

US Pre-Grant Publication Full-Text Database
 US Patents Full-Text Database
 US OCR Full-Text Database
 EPO Abstracts Database
 JPO Abstracts Database
 Derwent World Patents Index
 IBM Technical Disclosure Bulletins

Search:

L1

Refine Search

Recall Text

Clear

Interrupt

Search History

DATE: Thursday, March 17, 2005 [Printable Copy](#) [Create Case](#)

<u>Set</u> <u>Name</u>	<u>Query</u>	<u>Hit</u> <u>Count</u>	<u>Set</u> <u>Name</u> result set
<i>DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=ADJ</i>			
L1	(ebr or (bevel adj edge)) same (cmp or polish\$4 or clean\$4 or remov\$3) same wafer	192	L1

END OF SEARCH HISTORY